



IFJ

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76993

Sadayuki OHNISHI

Appln. No.: 10/646,709

Group Art Unit: 2814

Confirmation No.: 9821

Examiner: Phat X. CAO

Filed: August 25, 2003

For: SEMICONDUCTOR DEVICE WITH INTERLAYER DIELECTRIC FILM AND
MANUFACTURING METHOD THEREOF (AS AMENDED)

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three month(s), extending the time for responding to the Office Action of December 1, 2005 to June 1, 2005.

A check for the statutory fee of \$1020.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: May 31, 2005

Respectfully submitted,

John K. Shin

Registration No. 48,409